



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Johannes Baur et al.                      Art Unit : 2812  
Serial No. : 10/657,841                                  Examiner : Savitri Mulpuri  
Filed : September 9, 2003  
Title : RADIATION-EMITTING SEMICONDUCTOR COMPONENT AND METHOD  
FOR PRODUCING THE SEMICONDUCTOR COMPONENT

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF MARCH 25, 2005

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Deposit

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